

**Kirigami Enhances Film Adhesion**

Journal:	<i>Soft Matter</i>
Manuscript ID	SM-ART-11-2017-002338.R1
Article Type:	Paper
Date Submitted by the Author:	22-Feb-2018
Complete List of Authors:	Zhao, Ruike; Massachusetts Institute of Technology, Mechanical Engineering Lin, Shaoting; Massachusetts Institute of Technology, Mechanical Engineering Yuk, Hyunwoo; Massachusetts Institute of Technology, Mechanical Engineering Zhao, Xuanhe; Massachusetts Institute of Technology, Mechanical Engineering, Civil and Environmental Engineering



Soft Matter

ARTICLE

Kirigami Enhances Film Adhesion

*Ruike Zhao^a, Shaoting Lin^a, Hyunwoo Yuk^a, and Xuanhe Zhao^{*ab}*

a Department of Mechanical Engineering, Massachusetts Institute of Technology, Cambridge, MA 02139, USA, E-mail: zhaox@mit.edu

b Department of Civil and Environmental Engineering, Massachusetts Institute of Technology, Cambridge, MA 02139, USA.

Abstract

Structures of thin films bonded on substrates have been used in technologies as diverse as flexible electronics, soft robotics, bio-inspired adhesives, thermal-barrier coatings, medical bandages, wearable devices and living devices. The current paradigm for maintaining adhesion of films on substrates is to make the films thinner, more compliant and adhesive, but these requirements can compromise the function or fabrication of film-substrate structures. For example, there are limits on how thin, compliant and adhesive epidermal electronic devices can be fabricated and still function reliably. Here we report a new paradigm that enhances adhesion of films on substrates via designing rational kirigami cuts in the films without changing the thickness, rigidity or adhesiveness of films. We find that the effective enhancement of adhesion by kirigami is due to i) shear-lag effect of the film segments; ii) partial debonding at the film segments' edges; and iii) compatibility of kirigami films with inhomogeneous deformation of substrates. While kirigami has been widely used to program thin sheets with desirable shapes and

mechanical properties, fabricate electronics with enhanced stretchability and design assembly of three-dimensional microstructures; this paper gives the first systematic study on kirigami enhancing film adhesion. We further demonstrate novel applications including kirigami bandage, kirigami heat pad and printed kirigami electronics.

Kirigami Enhancing Film Adhesion: Mechanisms and Applications to Kirigami Wearables

1. Introduction

Structures of films bonded on substrates are used in diverse technological applications such as flexible electronics¹⁻⁵, soft robotics⁶⁻⁸, bio-inspired adhesives⁹⁻¹², thermal-barrier coatings¹³, medical bandages¹⁴, wearable devices¹⁵⁻²⁰ and living devices^{21, 22}. While maintaining adhesion of films on substrates is critical in these applications, the films are usually prone to delamination failure when the substrates are highly deformed. For example, skins on human elbow, knee, wrist and ankle can be highly stretched during body motions, and films such as bandages and wearable devices attached on these regions may get detached. **Fig. 1a** illustrates the debonding process of a continuous film bonded on a thick substrate under deformation²³⁻²⁸. As the substrate is stretched, the film initially deforms with the substrate. However, when the strain in the substrate reaches a critical value, a crack propagates along the interface and the film eventually detaches from the substrate^{22, 29}. In order to maintain the adhesion of films on substrates, thinner and more compliant films and tougher interfaces have been proposed^{23, 24, 28-31}. However, in many cases, it is challenging to vary the thickness or rigidity of the films or tune the interfacial toughness. For example, there are limits on how thin, compliant and adhesive epidermal electronic devices can be fabricated and still function reliably^{29, 32}. Therefore, new methods to enhance film adhesion are of critical importance in various technological applications of film-substrate structures.

Here we show that rationally-designed kirigami cuts in a film on substrate can greatly enhance the critical strain for overall detachment of the film, especially on substrate undergoing inhomogeneous deformation. We find that the effective enhancement of adhesion by kirigami is

due to i) shear-lag effect of the film segments; ii) partial debonding at the film segments' edges; and iii) compatibility of kirigami films with inhomogeneous deformation of substrates (**Fig. 1b**). This new mechanism on enhancing film adhesion by kirigami has been validated by numerical simulation and experiments (**Fig. 2-4**), and its application has been demonstrated by the example of kirigami bandage that achieve much enhanced adhesion on skin without changing thickness or rigidity of films or film-substrate interfaces (**Fig. 4**). In particular, we find that the kirigami film can better accommodate the deformation of wavy conductive wires adhered on or embedded in the films without delamination than continuous films³²⁻³⁴ (**Fig. 5**). We further demonstrated the novel applications of kirigami-wavy wire structure including kirigami heat pad and printed kirigami wearable electronics (**Fig. 6**). While kirigami has been intensively studied for programming thin sheets with desirable shapes and mechanical properties³⁵⁻⁴¹, fabricating stretchable electronics with enhanced stretchability⁴², and designing assembly of 3D structures⁴³⁻⁴⁶; to our knowledge, this is the first time kirigami has been harnessed to enhance effective adhesion of films on substrates with broad applications ranging from adhesive bandages to wearable electronics.

2. Numerical simulations

Two-dimensional (2D) finite element models are established to calculate the energy release rates for both initiation and propagation of the film-substrate debonding. The simulations are implemented by commercial software package ABAQUS/Standard with plane-strain element CPE4RH. Both film and substrate are represented by incompressible neo-Hookean material which has the strain energy density of

$$U = \frac{\mu}{2} \left[J^{-\frac{2}{3}} (\lambda_1^2 + \lambda_2^2 + \lambda_3^2) - 3 \right] + \frac{K}{2} (J - 1)^2, \quad (1)$$

where μ and K are the shear and bulk modulus of the material that are measured from experiments, and λ_i are the principal stretches, $J = \lambda_1 \lambda_2 \lambda_3$. To simulate the film-substrate structure, the film and substrate have the shear moduli and thicknesses of (μ_f, H_f) and (μ_s, H_s) , respectively. As shown in the finite-element models for debonding initiation in **ESI† Fig. S1** and debonding propagation in **ESI† Fig. S2**, we simulate half of the structure owing to the mirror symmetric condition. The substrate is considered to be much thicker than the film ($H_s \gg H_f$).

The energy release rate G is calculated by evaluating the energy released to propagate a crack by a unit length. Thereafter, we divide the energy release rate by $\mu_f H_f$ to give a dimensionless value.

For debonding initiation (**Fig. 2**), the film-substrate structure has width L at the reference state (**ESI† Fig. S1a**) and a lateral stretch λ is applied to the substrate (**ESI† Fig. S1b**). Next, a case with a prescribed crack length R (**ESI† Fig. S1c**) is stretched to the same amount (**ESI† Fig. S1d**) and the crack length changes to r at the current state. The energy release rate G is calculated as the energy difference between the crack-free case and the cracked case, then divided by the crack length at the reference state. For debonding propagation (**Fig. 3**), the initial adherent film segment width is L , and the analyzed adherent film segment widths are L_A . Then, the same procedure as described for calculating energy release rate of debonding initiation is followed (**ESI† Fig. S2**).

To compare the simulation results with the experimental results on critical debonding stretch as shown in **Fig. 3e** and **f**, the parameters in the numerical model are set to be the same as experimentally measured values. The corresponding energy release rate G is calculated as a

function of applied stretch λ . By setting the calculated G equal to interfacial toughness Γ , we calculate the corresponding critical stretches λ_c for delamination from FEM and compare the critical stretches with the experimental results.

3. Materials and methods

3.1. Fabrication of film-substrate system. In this paper, the fabrications of soft materials for film-substrate system were conducted using two types of silicone rubbers: PDMS (DowCorning Sylgard 184 Silicone Elastomer Kit) for fabrication of films and Ecoflex (Smooth-On EcoflexTM 00-30) for fabrication of substrates. PDMS films with different moduli were fabricated by mixing resin and crosslinker with weight ratio of 30:1, and 15:1 (DowCorning Sylgard 184 Silicone Elastomer Kit), and then curing for 5 h at 90 °C. The corresponding shear moduli are measured to be 27 kPa and 128kPa, respectively (fitted by neo-Hookean material constitutive law as shown in **ESI† Fig. S5**). The Ecoflex substrate was fabricated by mixing two components of the Ecoflex 00-30 with the weight ratio of 1A:1B, and then curing for 2 hours at room temperature. The corresponding shear modulus of the Ecoflex was measured to be 20 kPa. The single layer PDMS film with shear moduli 27 kPa or 128kPa was attached on the Ecoflex substrate, giving the film-substrate modulus ratio 1.4 or 6.4, respectively. To make the fabricated PDMS film adhesive, a layer of silicone adhesive (WACKER SiGel 613) was made by mixing resin and crosslinker with 10:1 weight ratio, spin-coating onto the fabricated PDMS films at the spin speed of 1000 r/min for 30 seconds, and then curing for 5 h at 60 °C. This gave an adhesive PDMS layer with thickness around 100 μm , much thinner than the film thickness (1.5mm).

3.2. Fabrication of inhomogeneous substrate. To achieve inhomogeneous deformation of a substrate under uniaxial tension, we fabricated an inhomogeneous substrate by bonding three material sections along the loading direction: two rigid PDMS sections on the sides with one compliant Ecoflex section in the middle (**Fig. 4a**). The PDMS sections were fabricated by mixing resin and crosslinker with weight ratio of 10:1 (DowCorning Sylgard 184 Silicone Elastomer Kit), and then curing for 5 h at 90 °C, which gave the corresponding shear modulus of 245kPa. The Ecoflex substrate was fabricated by mixing two components of the Ecoflex 00-30 with the weight ratio of 1A:1B, and then curing for 2 hours at room temperature, which gave the corresponding shear modulus of 20 kPa. Thereafter, a thin Ecoflex layer with the thickness of 0.5 mm was cured on top of the inhomogeneous substrate surface to ensure the same surface adhesion on the substrate.

3.3. Fabrication of adhesive PDMS film with kirigami design. PDMS sheets with designed kirigami cuts were fabricated by pouring the mixed resin and crosslinker with weight ratio of 10:1 (DowCorning Sylgard 184 Silicone Elastomer Kit) to 3D-printed molds. A layer of silicone adhesive (WACKER SiGel 613) was made by mixing resin and crosslinker with 10:1 weight ratio, spin-coating onto the fabricated PDMS films at the spin speed of 1000 r/min for 30 seconds and then curing for 5 h at 60 °C, which gave an adhesive PDMS layer with thickness around 100 μm, much thinner than the film thickness (1.5mm).

3.4. Fabrication of kirigami film with embedded heating module. The kirigami film was prepared by pouring the two components of the Ecoflex 00-30 with the weight ratio of 1A:1B to a 3D-printed mold. For the heating module, we used 0.1mm-diameter AWG38 Nichrome resistance heating wire. The heating wire was then stitched to the Ecoflex kirigami film with designed sinusoidal shape as illustrated in **Fig. 5a**. Another thin layer of Ecoflex was cured on

the kirigami film to fully encapsulate the heating wire. A layer of adhesive (WACKER SiGel 613) was then spin coated on to the prepared film. To heat up the heating wire, a 3V DC input was introduced by DC power supply (Agilent). A thermal imaging camera (Seek Thermal CompactPro Imaging Camera for iPhone) was used to monitor the surface temperature of the kirigami film.

3.5. Fabrication of kirigami film with embedded stretchable electronic device. The kirigami film was prepared by introducing kirigami cuts to a PDMS sheet with adhesive backing (McMaster) by a laser cutter (EPILOG LASER). The electrical circuit was printed onto the kirigami substrate by a customized 3D printer consists of XYZ robotic gantry (Aerotech) and microdispensers (Ultimus V; Nordson EFD). The printing paths for the electrical circuit were generated with G-code. A commercial silver ink (DuPont ME603) was used as a conductive ink and 200 μm nozzle (Nordson EFD) was used to print the ink. After printing circuit onto the kirigami substrate, four parallel aligned LEDs were placed onto desired locations and the assembly was cured in the oven for 2 hours at 120 °C. To light up the LEDs, a 3V DC input was introduced by the DC power supply (Agilent).

3.6. Measurement of energy release rate for steady-state crack propagation at the film-substrate interface. Many experimental techniques and models have been developed to evaluate the interfacial toughness of thin film adhesives^{23, 47, 48}. In our case, we measured the interfacial adhesion energy of the film-substrate system fabricated in Section 3.1 by the 90° peeling test, which gave the adhesion energy of 1 J/m^2 (**Fig. S3, ESI†**). In order to evaluate the critical energy release rate for steady-state crack propagation, we introduced initial cracks at both edges of the film prior to applied the load, as shown in **ESI† Fig. S6**. Then, we used universal test machine (2 kN load cell; Zwick/Roell Z2.5) to stretch the film-substrate system. The critical

stretch for steady-state crack propagation was identified when the adherent film segment started to detach, as illustrated in **ESI† Fig. S6** and **Movie S7**.

4. Results and Discussion

Consider a film with thickness H_f bonded to a thick stretchable substrate with thickness H_s . Without losing generality, both the film and the substrate are taken as incompressible neo-Hookean materials with initial shear moduli of μ_f and μ_s , respectively. The film-substrate structure is assumed to undergo plane-strain deformation with an applied substrate stretch λ , defined as the ratio between the structure's lengths along the stretching direction in the current and undeformed states. The elastic energy stored in the film drives the film's delamination from the substrate, and the adhesion energy between the film and substrate prevents the debonding. The energy release rate G is defined as the reduction of the film-substrate structure's elastic energy when the film delaminates by a unit area, and the interfacial toughness Γ as the work required to separate the film from substrate by a unit area. At a critical stretch λ_c , when the energy release rate G reaches the interfacial toughness Γ , the film begins to delaminate from the substrate. By dimensional argument, we can express the energy release rate as

$$G = \mu_f H_f f, \quad (2)$$

where f is a dimensionless function of applied stretch λ , modulus ratio μ_f/μ_s and geometry of the structure^{23, 29}. If the film is continuous as illustrated in **Fig. 1a**, the energy release rate for steady-state propagation of an interfacial crack can be expressed as $G = \mu_f H_f (\lambda^2 + \lambda^{-2} - 2)/2$. When the applied stretch reaches the critical value λ_c , the film will mostly debond from the substrate (except for a small segment of attachment). In the following paragraphs, we will discuss the

mechanisms how the kirigami in films can significantly increase the critical stretches for delamination.

4.1. Design of kirigami pattern

To focus on kirigami's effect on adhesion of films, we adopt a simple kirigami pattern in the current study. As illustrated in **Fig. 1b**, a row of cuts with equal length C and equal length of gap between two adjacent cuts D are applied in a film, perpendicular to the stretching direction. In an adjacent parallel row with distance L , the same cuts are repeated but shifted up by $(C+D)/2$. In this way, a pattern of kirigami is generated by repeating the parallels rows of cuts and keeping the same distance L between adjacent rows. The width of kirigami cuts is negligible in the current study, i.e., no subtraction of film material during the cut. In addition, the length of cuts C is much larger than gap length between adjacent cuts D and distance between adjacent rows of cuts L , so that each resultant film segment can be approximately taken to undergo plane-strain deformation.

4.2. Shear-lag effect in delaying film-substrate debonding

A cross section of the kirigami-film-substrate structure along the stretching direction is illustrated on **Fig. 2a**. When the substrate is stretched, the edges of each film segment undergo shear deformation prior to delamination, as illustrated in the schematic and experimental images in **Fig. 2b**, with the experimental image shown in **Fig. 2c**. The shear lag can reduce the energy release rate of kirigami films compared with the corresponding continuous films under the same applied stretch, and allows the film to bear larger stretch prior to debonding. The shear-lag effect is especially significant when the width of film segment L is comparable with the film thickness H_f .

To quantitatively understand the shear-lag effect of film segments on adhesion, we calculate the energy release rate G for the initiation of delamination in a unit cell of the kirigami film-substrate system using commercial software package ABAQUS/Standard (**Fig. S1**, ESI†). In the simulation, the substrate is considered to have infinite depth (i.e., $H_s \gg H_f$). Therefore, the normalized energy release rate for the initiation of delamination $G/H_f\mu_f$ can be expressed as

$$\frac{G}{H_f\mu_f} = f\left(\lambda, \frac{\mu_f}{\mu_s}, \frac{L}{H_f}\right). \quad (3)$$

Fig. 2d, e give the simulation results of the normalized energy release rate $G/H_f\mu_f$ as functions of the film segment size L/H_f , applied stretch λ and film-substrate modulus ratio μ_f/μ_s . For each fixed value of stretch λ and modulus ratio μ_f/μ_s , the normalized energy release rate $G/H_f\mu_f$ indeed increases with film segment size L/H_f and reaches a plateau at very large values of L/H_f (i.e., over 100). The reduction of the energy release rate with decreasing L/H_f is more pronounced for systems with higher stretch λ (**Fig. 2d**) and higher modulus ratio μ_f/μ_s (**Fig. 2e**).

4.3. Effect of partial delamination of film segments in delaying film-substrate debonding

Although the shear-lag effect can delay the initiation of delamination, the edges of film segments will eventually begin to debond from the substrate under a critical stretch. However, the delamination process will stop before the film segments are fully detached from the substrate, due to the reduction of energy release rate with interfacial crack propagation (**Fig. 1b** and **Fig. 3b**); and the middle regions of the film segments can still bond on the substrate. Therefore, the kirigami film can maintain overall adhesion on the substrate, despite partial delamination, under applied stretches that would have delaminated the corresponding continuous films.

To quantitatively understand the partial delamination's effect on enhancing film adhesion, we calculate the energy release rate G for the propagation of delamination in a unit cell of the kirigami film-substrate system (**Fig. S2**, ESI†). **Fig. 3b** illustrates the cross section of partially delaminated film segments on a stretched substrate, with the experimental image shown in **Fig. 3c**. The width of the adherent region between film segment and substrate at undeformed reference state is denoted as L_A . When the substrate undergoes applied stretch, the width of the adherent film segment is l_A at the current state. The energy release rate for propagation of interfacial crack in the adherent region can then be expressed as

$$\frac{G}{H_f \mu_f} = f \left(\lambda, \frac{\mu_f}{\mu_s}, \frac{L}{H_f}, \frac{L_A}{H_f} \right). \quad (4)$$

To focus on partial delamination's effect, we fix the width of kirigami film segment to be $L/H_f = 150$ and calculate energy release rate as a function of the applied stretch λ , modulus ratio μ_f/μ_s , the width of remaining adherent film segment L_A/H_f , as shown in **Fig. 3d, e**. For various values of modulus ratios μ_f/μ_s and applied stretches λ , when the interfacial crack is propagating away from the edges of film segment (i.e., after crack initiation), the normalized energy release rate $G/H_f \mu_f$ decreases drastically and reaches the value for steady-state propagation $G/\mu_f H_f = (\lambda^2 + \lambda^{-2} - 2)/2$. As the interfacial crack further propagates and the adherent width L_A reaches to a few times of film thicknesses (e.g., $20H_f \sim 50H_f$), the energy release rate decreases from the steady-state value (shown by dashed lines in **Fig. 3d, e**). Therefore, a higher applied stretch is required to further delaminate the adherent film segments than the critical stretch for steady-state propagation of interfacial crack in the corresponding continuous film. In addition, the effect of partial delamination (i.e., decreasing

L_A/H_f) on reducing energy release rate is more pronounced in systems with higher modulus ratio μ_f/μ_s as shown in **Fig. 3e**.

We next experimentally validate the partial delamination's effect on delaying interfacial debonding, by measuring the critical stretches for delamination and compare the experimental results with simulations. In the experiments, PDMS and Ecoflex are used to fabricate the film and substrate with thicknesses of 1.5 mm and 12.5 mm, respectively. The shear modulus of the substrate is measured to be $\mu_s = 20$ kPa, and the moduli of the film with different crosslinking densities to be $\mu_f = 27$ kPa and 128 kPa. The film-substrate interfacial toughness is measured to approximate $\Gamma \approx 1\text{J}/\text{m}^2$ (**Fig. S3, ESI†**). The width of the film segment is set to be $L = 90\text{mm}$, and a number of typical adherent segment widths are chosen in the tests from $L_A = 4.5\text{mm}$ to $L_A = 90\text{mm}$. For each modulus ratio and adherent segment width, the Ecoflex substrates are stretched to critical stretches until the crack begins to propagate in the adherent region (**Fig. S6, ESI†**). The experimentally measured critical stretches λ_c for various values of μ_f/μ_s and L_A/H_f have been plotted in **Fig. 3f, g**. In comparison, we set the values of μ_f/μ_s , L/H_f , and L_A/H_f in the numerical model to be the same as experimental values, and then calculate the corresponding energy release rate G as a function of applied stretch λ . By setting the calculated G equal to the measured interfacial toughness Γ , we calculate the corresponding critical stretches λ_c for delamination and compare the experimental and simulation results in **Fig. 3f, g**. The numerical model can consistently predict the critical stretch for interfacial crack propagation in adherent film segments. In addition, both the experimental and simulation results validate that partial delamination in kirigami film segments can significantly enhance critical stretches for delamination.

4.4. Kirigami film accommodating inhomogeneous deformation of substrate

In many applications such as bandages and wearable devices, the deformation of the substrates can be inhomogeneous. For example, skins right above the joints in human body can be deformed much more significantly than adjacent regions during rotational movements of the joints. Adherent films usually cover both the joint and adjacent regions. As a result, the part of a continuous film adhered on joint regions can be highly stretched during body motion to give high energy release rate for delamination propagation. On the other hand, the part of a kirigami film (**Fig. 1b**) adhered on joint regions may be partially or fully detached during body motion; however, the part of kirigami film on adjacent regions can still maintain its adhesion due to low energy release rate for delamination in adjacent regions.

We next demonstrate kirigami's effect on adhesion of films on substrates undergoing inhomogeneous deformation. As illustrated in **Fig. 4a**, an inhomogeneous substrate is fabricated with Ecoflex with shear modulus of 20kPa in the middle (width 30mm) and PDMS with shear modulus of 245kPa on the sides (width 25mm). A thin layer of Ecoflex is further coated on the surface of the substrate to ensure same surface adhesion of the inhomogeneous substrate. We next uniaxially stretch the substrate to different levels and use Digital Image Correlation (DIC) to measure strain distribution in the substrate. **Fig. 4b** indicates that the designed substrate can effectively give inhomogeneous deformation to approximate the deformation around joint regions in the body. In addition, PDMS with thickness of 1.5mm and shear modulus of 128kPa is selected as the continuous film. To fabricate the kirigami film, the periodic cuts illustrated in **Fig. 1b** are applied on the corresponding continuous film with $L=7.0\text{mm}$ $C=19.0\text{mm}$ and $D=3.0\text{mm}$. The continuous or kirigami film is physically attached on the inhomogeneous substrate, which is then subjected to uniaxial tension. As shown in **Fig. 4c**, the continuous film begins to delaminate

from the substrate under relatively low applied stretch (i.e., $\lambda=1.05$), with the black dashed line indicating the boundary of the detached region. Under the same stretch (i.e., $\lambda=1.05$), the kirigami film only shows the initiation of partial debonding at the edges of the film segments (**Fig. 4d**). As the applied stretch increases to higher values (e.g., $\lambda=1.25$), the continuous film detaches from one side of the substrate. On the contrary, under the same high stretch ($\lambda=1.25$), the kirigami film only partially delaminates from the highly-stretched middle region of the substrate, while maintains good adhesion on the less-stretched side regions (**Movie S1, ESI†**). Delamination tests are further done on conventional medical bandage (3M™ Elastic Adhesive Bandage, thickness 0.3mm) and the same bandage with kirigami cuts ($L=1.8\text{mm}$ $C=14.0\text{mm}$ and $D=2.6\text{mm}$) on the same inhomogeneous substrate. **ESI† Fig. S4** and **Movie S2** demonstrate the significantly enhanced adhesion of kirigami bandage over continuous bandage on substrate undergoing inhomogeneous deformation. Besides the three major factors (film shear lag, partial debonding, and accommodation of inhomogeneous deformation) that explains the mechanism of kirigami film enhancing interface adhesion, there are other potential factors such as buckling, twisting, in-plane and out of plane rotation of the film segments, which may also affect interfacial debonding^{35,37,49}.

Next we demonstrate that the kirigami film can significantly enhance adhesion on skins above moving joints of human body compared with continuous films. We attach the continuous or kirigami film (PDMS with overall dimension of $110.0\text{ mm}\times 69.0\text{ mm}\times 1.5\text{ mm}$, shear modulus of 128kPa , $L = 7.0\text{mm}$, $C = 19.0\text{mm}$ and $D = 3.0\text{mm}$) on the elbow of an arm in the straight state (i.e., 180° angle). Thereafter, we bend the elbow to states of 90° and 45° angles. From **Fig. 4e, f** and **ESI† Movie S3**, it can be seen that the continuous film delaminates easily from the elbow during bending motion. On the other hand, the kirigami film can maintain overall adhesion on

the elbow even under severe bending (45° angle), despite partial delamination right above the joint.

4.5. Kirigami film-wavy wire structure

Wearable electronics in the form of thin films adhered on various parts of the body have been intensively developed over the last decade^{3, 50, 51}. However, it is still challenging to maintain reliable adhesion of thin-film wearable electronics on deforming body parts such as joints^{52, 53}. In addition, the delamination and fracture of electronic components on highly stretched thin films still causes serious reliability issues to wearable electronics⁵⁴. Here we will demonstrate a new type of wearable devices based on kirigami films that can significantly enhance the effective adhesion and reduce the strains in the kirigami films compared with corresponding continuous films. As a result, the kirigami wearable devices can reliably adhere on moving joints and maintain the bonding of electronic components on them.

Rigid metallic and semiconductor materials have been made into wires of wavy (or serpentine) shapes and bonded on compliant films to enhance the stretchability of these rigid materials^{2, 55-59}. When the film-wavy wire structure is stretched, the maximum strain in the rigid wire can be significantly reduced compared with bulk material under the same stretch. However, the rigid wire still constrains the deformation of stretched film right beneath it, potentially driving the debonding of wire from the film^{29, 32, 33}. Here we will show that the strain in a kirigami film (and thus mismatch strain between film and wire) can be significantly reduced compared with the corresponding continuous film under the same stretch, delaying delamination of wire from kirigami film. The deformation of continuous film-wavy wire structure will be compared with the corresponding kirigami film-wavy wire structure under the same stretch.

Since the rigid wire cannot cross the kirigami cuts, without loss of generality we make the wavy wire to follow a sinusoidal shape with wavelength $\omega=2L$ and amplitude $A=(C+D)/4$, and set peak and valley points of the sinusoidal wire to overlap with the middle points of gaps between adjacent cuts in a row, as illustrated in **Fig. 5a**. For comparison, a rigid wire with the same sinusoidal shape is attached on the corresponding continuous film (**Fig. 5b**).

Thereafter, we simulate the deformation of continuous film-wavy wire structure and kirigami film-wavy wire structure in a plane to approximate their deformation on substrates, using ABAQUS. (Note the approximation also accounts for partial delamination of kirigami film to allow opening of the cuts.) In the simulation, we set the width and height of the rigid wire to be $2H_f$ and H_f , respectively; the wire-film modulus ratio $\mu_{wire}/\mu_f = 10^5$; and the kirigami parameters $L=70H_f$, $C=190H_f$, and $D=30H_f$. Then we uniaxially stretch representative segments (**Fig. 5b**) of the film-wavy wire structures in the simulation to a typical stretch $\lambda=1.5$. As shown in **Fig. 5d**, while most of the regions in the continuous film are stretched to a strain over $\varepsilon_{xx} = 0.5$ (nominal strain), the rigid wire constrains the deformation of film around it and causes high mismatch strain at the film-wavy wire interface, potentially driving the delamination of rigid wires³². On the other hand, the strain in the kirigami film is much reduced (around $\varepsilon_{xx} = 0.07$) compared with the continuous film under the same stretch ($\lambda=1.5$), due to the opening of cuts in the kirigami film resulted from its partial delamination (e.g., **Fig. 4d, f**, experimental figures in the paper showing the opening). As a result, the mismatch strain between kirigami film and rigid wire and thus the driving force for wire debonding have been significantly reduced, which gives more reliable wire adhesion on the kirigami film than on the corresponding continuous film (**Fig. 5c**).

4.5.1. Kirigami heat pad

Heat pads can conformally attach to the joints of human body and potentially help relieve the pain in joints by on-demand heating^{60,61}. While wearable heat pads have been developed, it is still challenging to maintain their adhesion on body parts undergoing large deformation such as the joints⁵². Here we demonstrate a kirigami heat pad that can reliably adhere on the knee under large bending and deformation. We select Ecoflex film with overall dimension 130.0 mm×69.0 mm×1.5 mm, and kirigami pattern with $L=7.0\text{mm}$ $C=19.0\text{mm}$ and $D=3.0\text{mm}$ to fabricate the kirigami pad. Thereafter, we deform Nichrome resistance heating wires (diameter 0.1mm, resistance 138.8ohms/m) into the corresponding wavy shape ($\omega=14.0\text{mm}$ $A=5.5\text{mm}$) and then bond them on the kirigami pad as shown in **Fig. 6a**. The kirigami pad shows remarkable good adhesion to the knee skin during large cyclic bending motion of the knee (0 to 90 degrees), as shown in **Fig. 6b, c** (see **ESI† Movie S4** for the adhesive performance of the kirigami heat pad under 100 knee-bending cycles). Once a DC voltage of 3V is applied to the heating wire, the kirigami heat pad increases its temperature while still maintains good adhesion on the knee during bending motion (**Fig. 6d, e**, and **Movie S5, ESI†** for the thermal imaging video for the kirigami heat pad deformation under 90-degree knee bending). In addition to the enhanced adhesion, the open slits on the kirigami heat pad can significantly enhance the breathability of heat pad, potentially leading to more comfortable wearing experience⁶².

4.5.2. Printed kirigami wearable electronics

The design of kirigami film-wavy wire structure and devices is also compatible with additive manufacturing method such as printing. As illustrated in **Fig. 6f**, an adhesive PDMS sheet with thickness of 0.7mm is selected as the film and a kirigami pattern with $L=7.0\text{mm}$,

$C=19.0\text{mm}$ and $D=3.0\text{mm}$ is applied on the film. Thereafter, a conductive silver ink (DuPont ME603) is printed on the kirigami film following a programmed wavy pattern with $\omega=14.0\text{mm}$ $A=5.5\text{mm}$ as demonstrated in **Fig. 6g** and **ESI† Movie S6**. Some discontinuous regions have also been programmed into the printing pattern of the conductive ink for attachment of other electronic components in later steps. The conductive silver ink is printed using $200\ \mu\text{m}$ nozzle with $300\ \text{mm/min}$ printing speed and $200\ \text{kPa}$ printing pressure. The motion path of the printing nozzle is programmed by G-code following the designed path. (see **ESI† Movie S6** for details on the printing process.) Thereafter, functional components such as LEDs can also be attached to designated regions of the kirigami device (**Fig. 6g**). Notably, the commercial conductive silver ink (DuPont ME603) also serves as adhesive upon curing, which provide robust adhesion and electrical contact between the kirigami device and electronic components such as LEDs. To demonstrate its function and wearability, we attach the fabricated device to the elbow of an arm in straight state, and then apply a DC voltage of 3V to the printed conductive wire to lighten the LEDs (**Fig. 6h**). When the elbow is bended, the kirigami device can maintain overall adhesion on the elbow and the printed wires maintain conductivity and attachment on the film, owing to the kirigami film-wavy wire design (**Fig. 6i**).

5. Conclusion

Kirigami has been intensively studied for programming thin sheets with desirable shapes and mechanical properties, enhanced stretchability of films, and designing assembly of 3D structure. In this paper, for the first time, we introduce designed kirigami cuts into films to significantly enhance their adhesion on substrates under large inhomogeneous deformation, without the need

to change the film's thickness, rigidity or adhesiveness. We show that the mechanisms of kirigami enhancing film adhesion include shear-lag effect of the film segments, partial debonding at the film segments' edges, and compatibility of kirigami films with inhomogeneous deformation of substrates. These mechanisms have been systematically explained and validated by combined theory, experiments and numerical simulation. We further propose kirigami film-wavy wire structures as a new strategy for the design of kirigami wearable devices with much enhanced adhesion on body parts undergoing large deformation such as heart and joints. Based on the new mechanisms and design, we further demonstrate novel and tangible applications including kirigami bandage, kirigami heat pad, and printed kirigami wearable electronics. In addition to wearable electronics, the kirigami strategy for enhancing film adhesion is expected to enable novel applications in diverse areas such as soft robotics, bio-inspired adhesives, medical bandages, and living devices, where robust film-substrate structures are critical but it is challenging to vary film's thickness, rigidity or adhesiveness.

Acknowledgements

The work is supported by Tibet Cheezheng Tibetan Medicine Co. Ltd, NSF (No. CMMI-1253495), ONR (No. N00014-14-1-0528) and Samsung.

Figures and Figure Captions

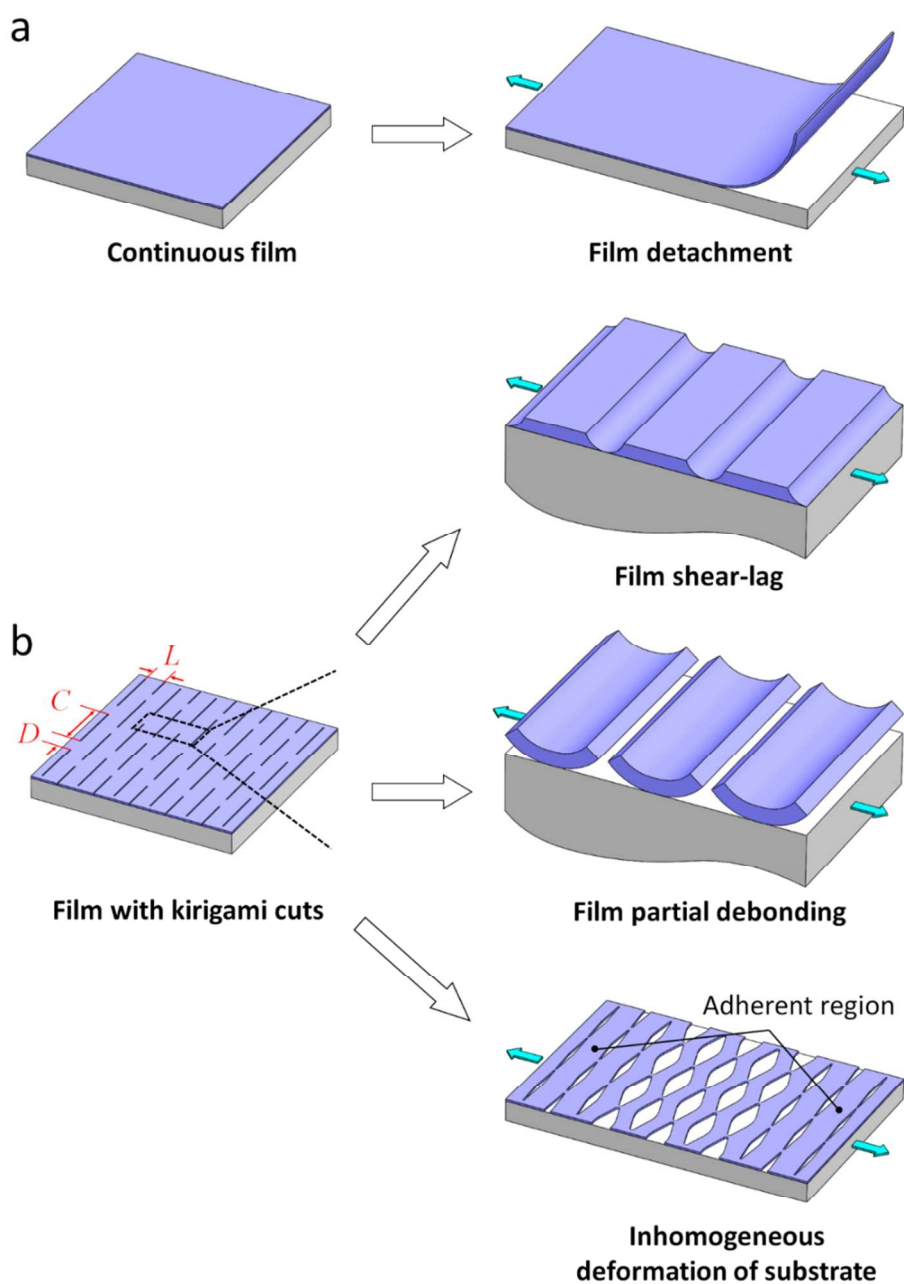


Fig. 1. Schematic illustration of mechanisms for kirigami enhancing film adhesion a) The continuous film delaminates from a substrate under critical strain. b) The film with designed kirigami cuts can significantly enhance the critical strain for delamination owing to shear-lag

effect of the film segments, partial debonding at the film segments' edges, and compatibility of kirigami films with inhomogeneous deformation of substrates.

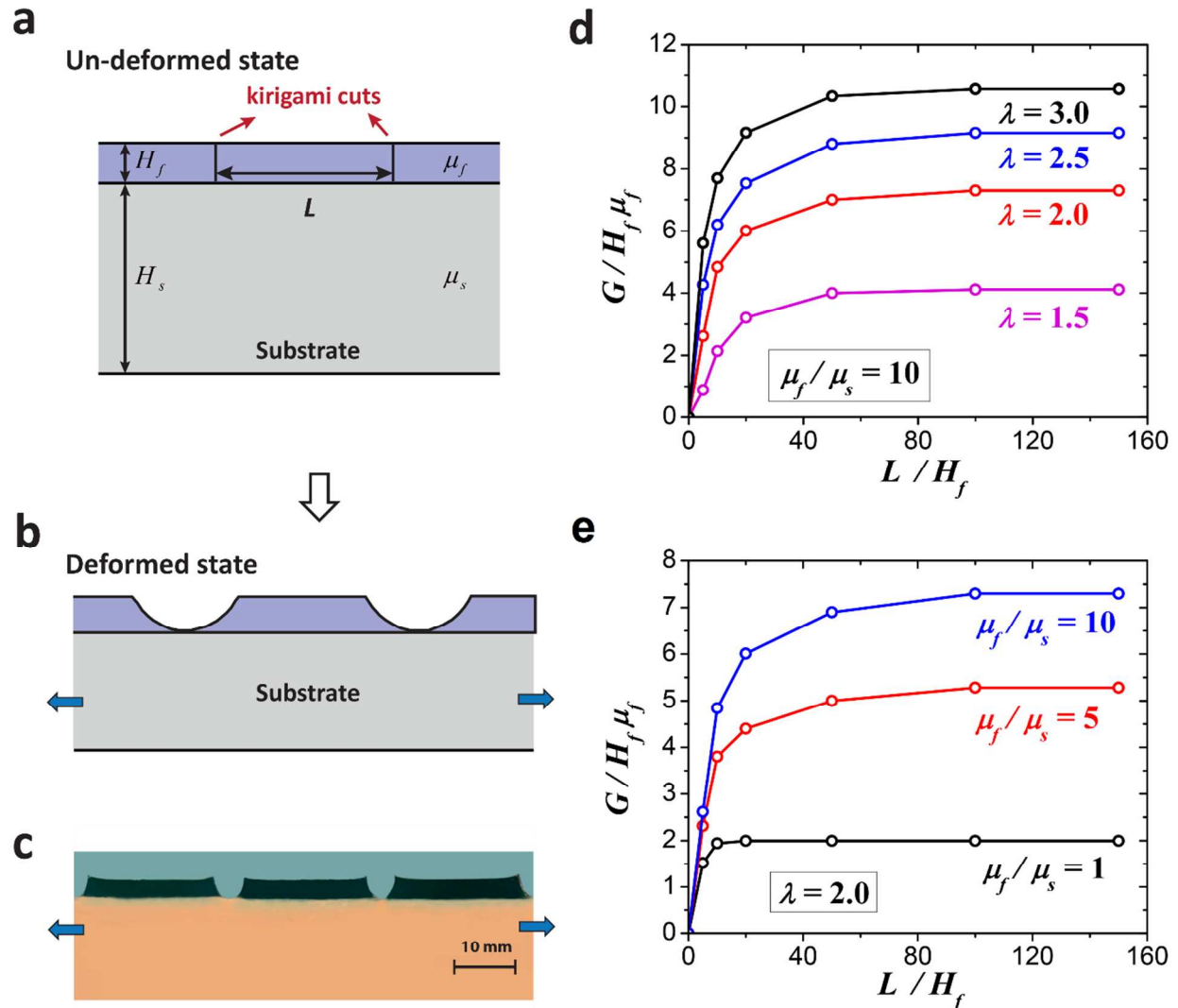
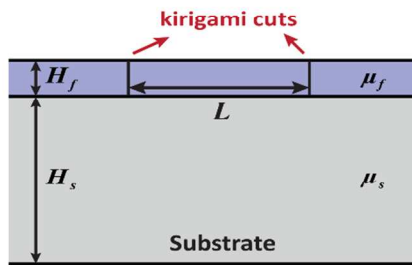


Fig. 2. Shear-lag effect of the film segments in a kirigami film. a) Schematic of the cross section of a film segment at the undeformed state. b) Deformation of film segments on a substrate under uniaxial stretch. The shear deformation around the edges of film segments gives the shear-lag effect, which reduces energy release rate compared with continuous film. c) Photo of deformed film segments on a substrate under uniaxial stretch. d) The normalized energy release rate $G/H_f \mu_f$ for debonding initiation as a function of film segment size L/H_f and applied

stretch λ with fixed film-substrate modulus ratio $\mu_f/\mu_s = 10$, calculated from finite-element model. e) The normalized energy release rate $G/H_f\mu_f$ for debonding initiation as a function of film segment size L/H_f and film-substrate modulus ratio μ_f/μ_s with fixed applied stretch $\lambda=2$, calculated from finite-element model.

a

Un-deformed state

**b**

Deformed state

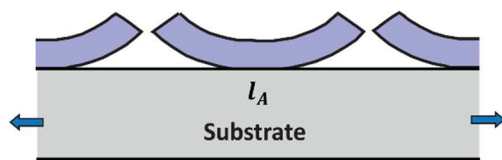
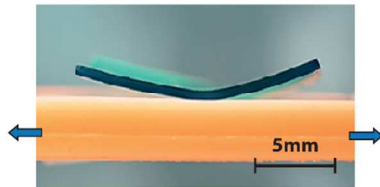
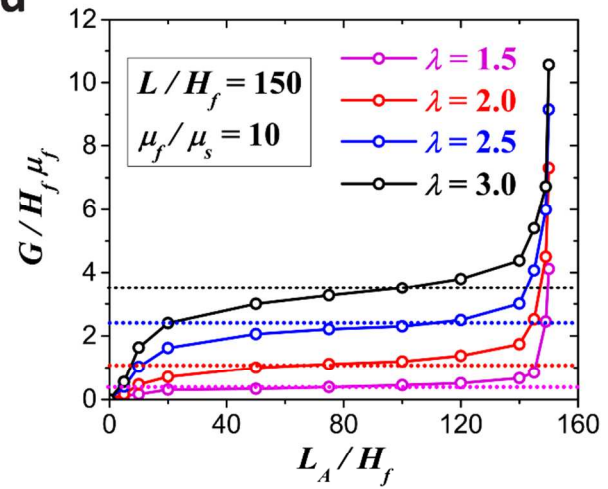
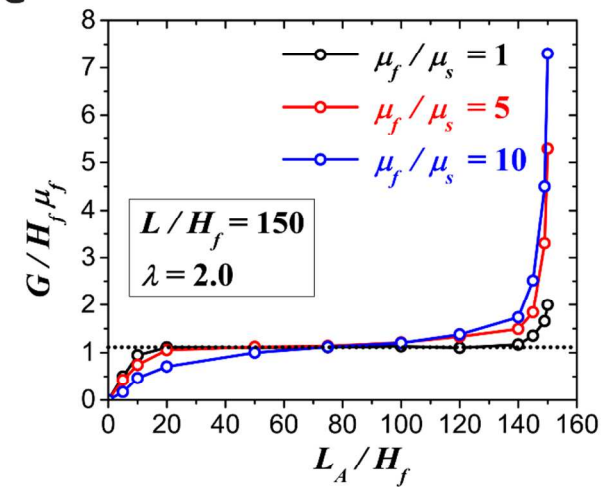
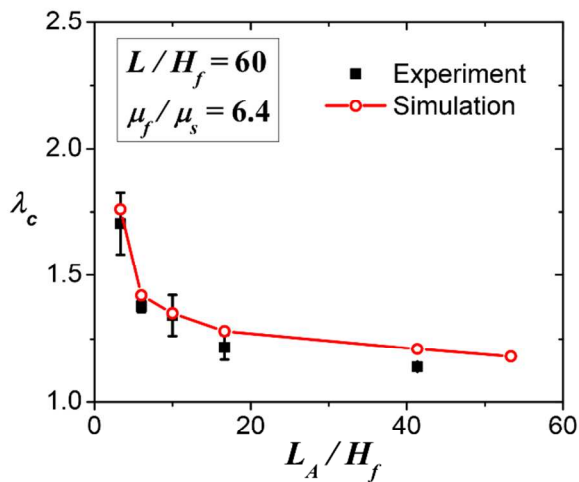
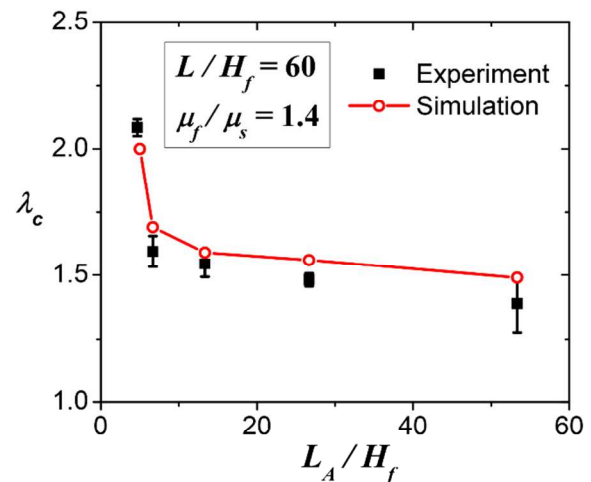
**c****d****e****f****g**

Fig. 3. Partial delamination of the film segments in a kirigami film. a) Schematic of the cross section of a film segment at the undeformed state. b) Partial delamination of film segments on a substrate under uniaxial stretch. c) Photo of the partial delaminated film segments on a substrate under uniaxial stretch. d) The normalized energy release rate $G/H_f\mu_f$ for debonding propagation as a function of adherent segment size L_A/H_f and applied stretch λ with fixed film-substrate modulus ratio $\mu_f/\mu_s = 10$ and initial film segment size $L/H_f = 150$, calculated from finite-element model. e) The normalized energy release rate $G/H_f\mu_f$ for debonding propagation as a function of adherent segment size L_A/H_f and film-substrate modulus ratio μ_f/μ_s with fixed applied stretch $\lambda=2$ and initial film segment size $L/H_f = 150$, calculated from finite-element model. f) Experimental validation of critical stretch λ_c for interfacial crack propagation as a function of adherent segment size L_A/H_f for a film-substrate structure with modulus ratio $\mu_f/\mu_s = 6.4$. g) Experimental validation of critical stretch λ_c for interfacial crack propagation as a function of adherent segment size L_A/H_f for a film-substrate structure with modulus ratio $\mu_f/\mu_s = 1.4$.

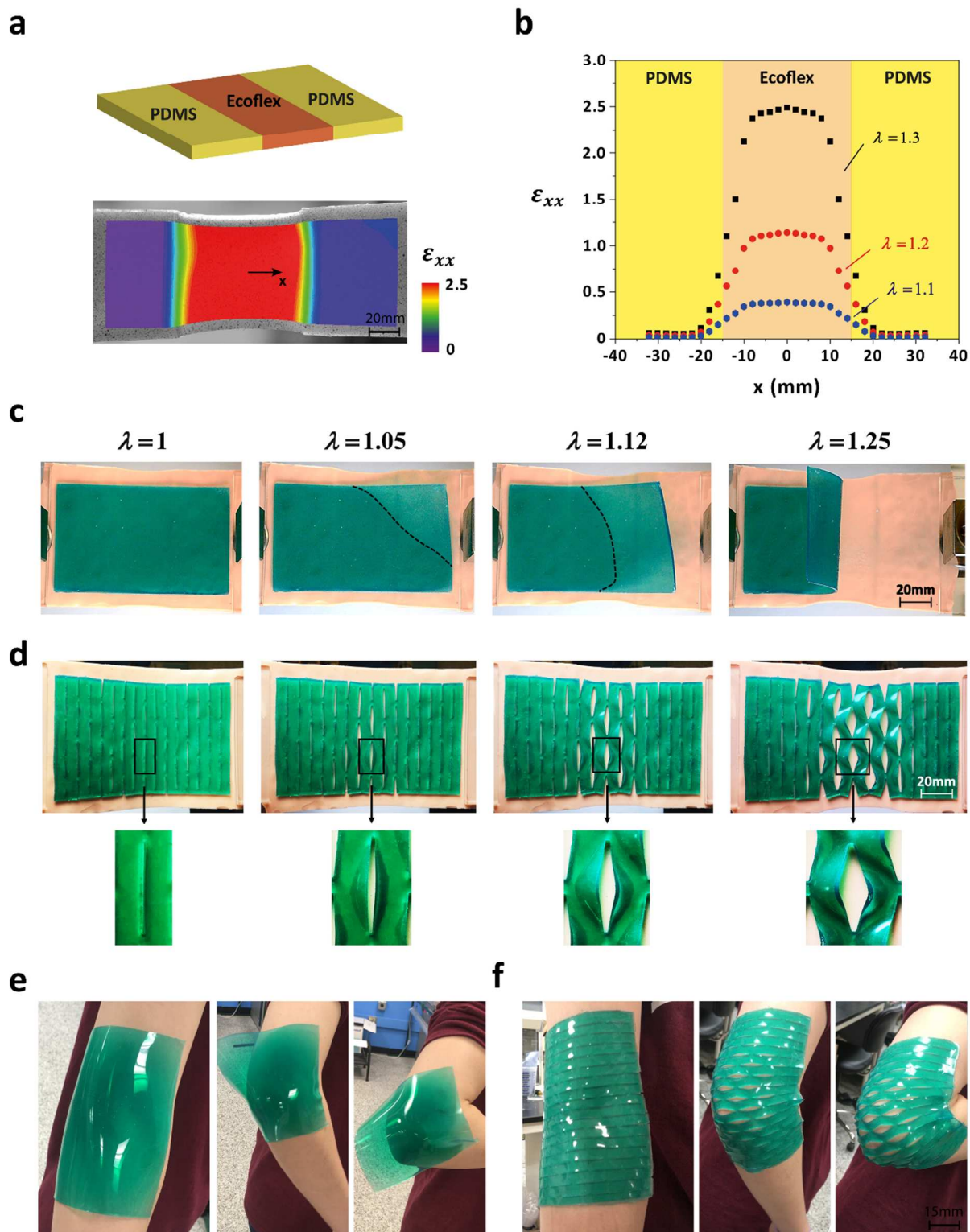


Fig. 4. Kirigami film on substrates undergoing inhomogeneous deformation. a) Design of a substrate with homogeneous rigidity that gives inhomogeneous deformation under uniaxial

stretch. b) Strain distribution ε_{xx} (nominal strain) on the substrate under applied stretch $\lambda=1.1$, 1.2 and 1.3, obtained by digital image correlation. c) Snapshots of a continuous film detaching from the substrate given in (a) under applied stretch up to $\lambda=1.25$. d) Snapshots of kirigami film deformation without delamination on the substrate given in (a) under applied stretch up to $\lambda=1.25$. e) A continuous film detaches from elbow during bending. f) The corresponding kirigami film maintains adhesion on the elbow during cyclic bending.

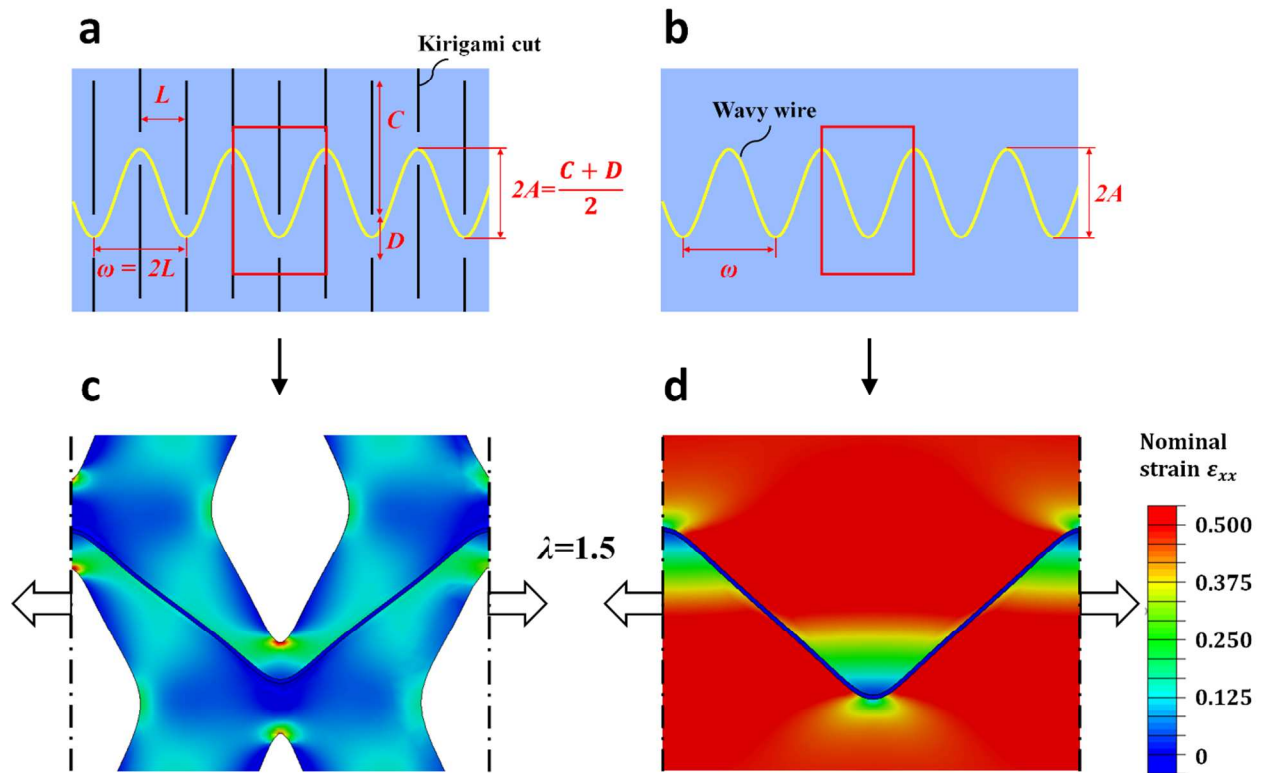


Fig. 5. Kirigami film-wavy wire structure enhancing effective wire adhesion. a) Design of the kirigami film-wavy wire structure, where the wire follows a sinusoidal shape with wavelength $\omega = 2L$ and amplitude $A = (C+D)/4$. b) The same wavy wire is bonded on the corresponding continuous film. c) Distribution of nominal strain ϵ_{xx} in the kirigami film-wavy wire structure under applied stretch $\lambda = 1.5$. d) Distribution of nominal strain ϵ_{xx} in the corresponding continuous film under applied stretch $\lambda = 1.5$.

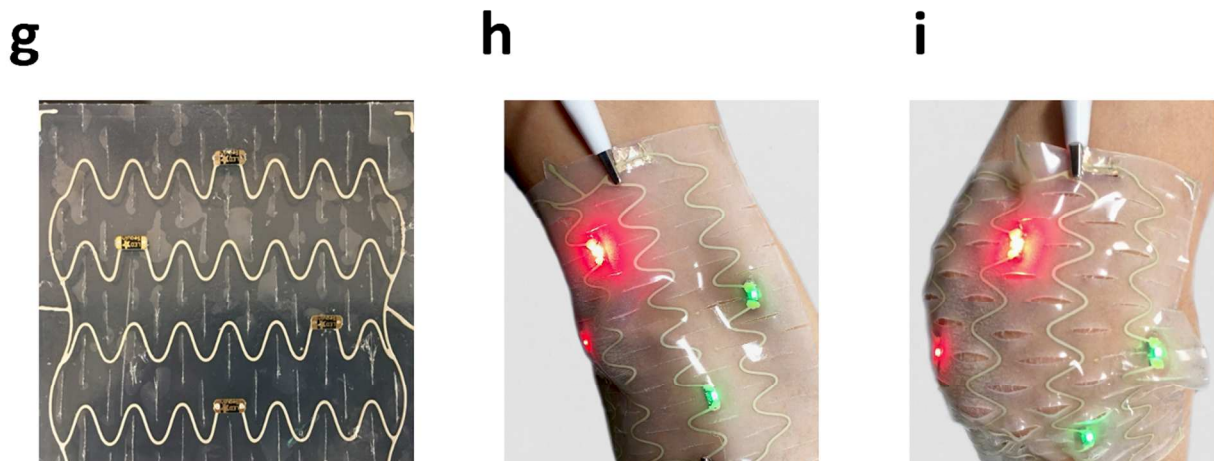
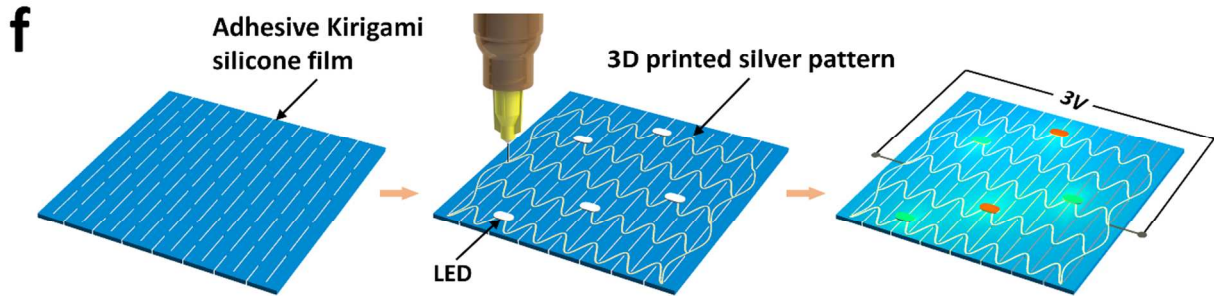
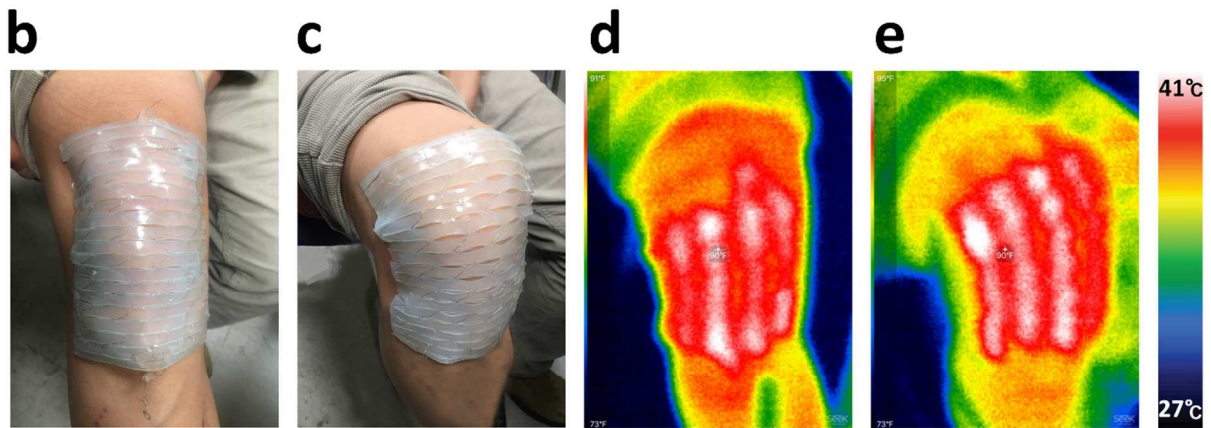
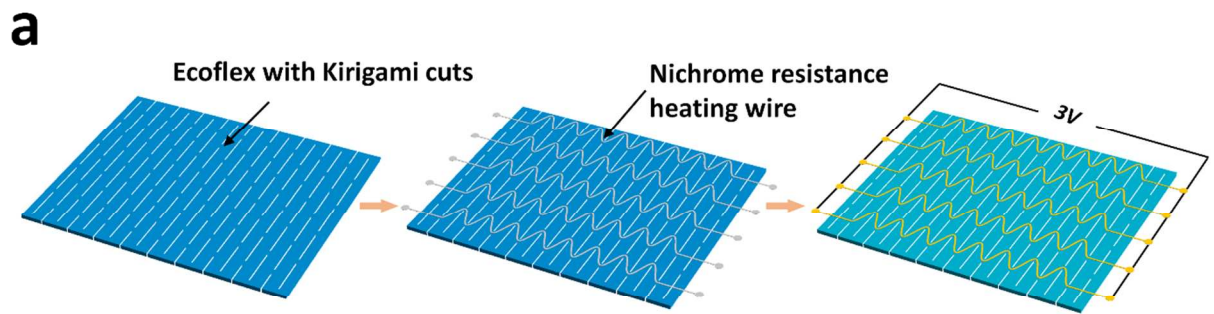


Fig. 6. Kirigami wearable devices. a-e) Design and demonstration of a kirigami heat pad. a) Schematic illustration of the design of kirigami heat pad. b) The kirigami heat pad is attached on a knee at straight state. c) The kirigami heat pad maintains adhesion on the knee under 90-degree knee bending over 100 cycles. d) and e) The corresponding thermal imaging of (b) and (c) after heating. f-i) Design and demonstration of a kirigami electronic device. f) Schematic illustration of the design of kirigami electronic device with attached LEDs. g) Photo of the kirigami electronic device. h) The kirigami electronic device is attached on an elbow at straight state. i) The kirigami electronic device maintains adhesion on the elbow under 90-degree elbow bending.

Reference

1. J. A. Rogers, T. Someya and Y. Huang, *Science*, 2010, **327**, 1603-1607.
2. C. H. Lee, Y. Ma, K.-I. Jang, A. Banks, T. Pan, X. Feng, J. S. Kim, D. Kang, M. S. Raj, B. L. McGrane, B. Morey, X. Wang, R. Ghaffari, Y. Huang and J. A. Rogers, *Advanced Functional Materials*, 2015, **25**, 3698-3704.
3. D.-H. Kim, N. Lu, R. Ma, Y.-S. Kim, R.-H. Kim, S. Wang, J. Wu, S. M. Won, H. Tao and A. Islam, *science*, 2011, **333**, 838-843.
4. M. Kaltenbrunner, T. Sekitani, J. Reeder, T. Yokota, K. Kuribara, T. Tokuhara, M. Drack, R. Schwödiauer, I. Graz and S. Bauer-Gogonea, *Nature*, 2013, **499**, 458.
5. M. S. White, M. Kaltenbrunner, E. D. Głowacki, K. Gutnichenko, G. Kettlgruber, I. Graz, S. Aazou, C. Ulbricht, D. A. Egbe and M. C. Miron, *Nature Photonics*, 2013, **7**, 811-816.
6. N. Lu and D.-H. Kim, *Soft Robotics*, 2014, **1**, 53-62.
7. C. Majidi, *Soft Robotics*, 2014, **1**, 5-11.
8. S. Bauer, S. Bauer - Gogonea, I. Graz, M. Kaltenbrunner, C. Keplinger and R. Schwödiauer, *Advanced Materials*, 2014, **26**, 149-162.
9. M. P. Murphy, B. Aksak and M. Sitti, *Small*, 2009, **5**, 170-175.
10. D. M. Drotlef, P. Blumler and A. del Campo, *Adv Mater*, 2014, **26**, 775-779.
11. L. F. Boesel, C. Greiner, E. Arzt and A. del Campo, *Adv Mater*, 2010, **22**, 2125-2137.
12. T. Zhang, Z. Zhang, K.-S. Kim and H. Gao, *Journal of Adhesion Science and Technology*, 2014, **28**, 226-239.
13. W. Zhu, L. Yang, J. W. Guo, Y. C. Zhou and C. Lu, *International Journal of Plasticity*, 2015, **64**, 76-87.
14. P. Zahedi, I. Rezaeian, S. O. Ranaei - Siadat, S. H. Jafari and P. Supaphol, *Polymers for Advanced Technologies*, 2010, **21**, 77-95.
15. Y. Khan, A. E. Ostfeld, C. M. Lochner, A. Pierre and A. C. Arias, *Adv Mater*, 2016, **28**, 4373-4395.
16. M. K. Kwak, H. E. Jeong and K. Y. Suh, *Adv Mater*, 2011, **23**, 3949-3953.
17. G. Schwartz, B. C. Tee, J. Mei, A. L. Appleton, D. H. Kim, H. Wang and Z. Bao, *Nat Commun*, 2013, **4**, 1859.
18. Y. Wang, L. Wang, T. Yang, X. Li, X. Zang, M. Zhu, K. Wang, D. Wu and H. Zhu, *Advanced Functional Materials*, 2014, **24**, 4666-4670.
19. C. Dagdeviren, B. D. Yang, Y. Su, P. L. Tran, P. Joe, E. Anderson, J. Xia, V. Doraiswamy, B. Dehdashti and X. Feng, *Proceedings of the National Academy of Sciences*, 2014, **111**, 1927-1932.
20. T. Yamada, Y. Hayamizu, Y. Yamamoto, Y. Yomogida, A. Izadi-Najafabadi, D. N. Futaba and K. Hata, *Nature nanotechnology*, 2011, **6**, 296-301.
21. X. Liu, T.-C. Tang, E. Tham, H. Yuk, S. Lin, T. K. Lu and X. Zhao, *Proceedings of the National Academy of Sciences*, 2017, **114**, 2200-2205.
22. S. Lin, H. Yuk, T. Zhang, G. A. Parada, H. Koo, C. Yu and X. Zhao, *Advanced Materials*, 2015.
23. J. Tang, J. Li, J. J. Vlassak and Z. Suo, *Soft matter*, 2016, **12**, 1093-1099.
24. Q. Wang and X. Zhao, *Sci Rep*, 2015, **5**, 8887.
25. L. B. Freund and S. Suresh, *Thin film materials: stress, defect formation and surface evolution*, Cambridge University Press, 2004.
26. H.-H. Yu and J. W. Hutchinson, *International Journal of Fracture*, 2002, **113**, 39-55.
27. D. Marshall and A. Evans, *Journal of Applied Physics*, 1984, **56**, 2632-2638.
28. H. Yuk, T. Zhang, S. Lin, G. A. Parada and X. Zhao, *Nature materials*, 2016, **15**, 190-196.
29. N. Lu, J. Yoon and Z. Suo, *International journal of materials research*, 2007, **98**, 717-722.
30. T. Zhang, H. Yuk, S. Lin, G. A. Parada and X. Zhao, *Acta Mechanica Sinica*, 2017, 1-12.
31. H. Yuk, T. Zhang, G. A. Parada, X. Liu and X. Zhao, *Nature Communications*, 2016, **7**.

32. O. van der Sluis, Y. Y. Hsu, P. H. M. Timmermans, M. Gonzalez and J. P. M. Hoefnagels, *Journal of Physics D: Applied Physics*, 2011, **44**, 034008.
33. J. P. M. Hoefnagels, J. Neggers, P. H. M. Timmermans, O. van der Sluis and M. G. D. Geers, *Scripta Materialia*, 2010, **63**, 875-878.
34. M. Gonzalez, F. Axisa, M. V. Bulcke, D. Brosteaux, B. Vandeveldel and J. Vanfleteren, *Microelectronics Reliability*, 2008, **48**, 825-832.
35. Y. Tang, G. Lin, S. Yang, Y. K. Yi, R. D. Kamien and J. Yin, *Adv Mater*, 2017, **29**.
36. Y. Tang, G. Lin, L. Han, S. Qiu, S. Yang and J. Yin, *Adv Mater*, 2015, **27**, 7181-7190.
37. T. C. Shyu, P. F. Damasceno, P. M. Dodd, A. Lamoureux, L. Xu, M. Shlian, M. Shtein, S. C. Glotzer and N. A. Kotov, *Nature materials*, 2015, **14**, 785-789.
38. Y. Tang and J. Yin, *Extreme Mechanics Letters*, 2017, **12**, 77-85.
39. V. Kunin, S. Yang, Y. Cho, P. Deymier and D. J. Srolovitz, *Extreme Mechanics Letters*, 2016, **6**, 103-114.
40. Y. Cho, J.-H. Shin, A. Costa, T. A. Kim, V. Kunin, J. Li, S. Y. Lee, S. Yang, H. N. Han and I.-S. Choi, *Proceedings of the National Academy of Sciences*, 2014, **111**, 17390-17395.
41. M. K. Blees, A. W. Barnard, P. A. Rose, S. P. Roberts, K. L. McGill, P. Y. Huang, A. R. Ruyack, J. W. Kevek, B. Kobrin and D. A. Muller, *Nature*, 2015, **524**, 204-207.
42. Z. Song, X. Wang, C. Lv, Y. An, M. Liang, T. Ma, D. He, Y.-J. Zheng, S.-Q. Huang and H. Yu, *Scientific reports*, 2015, **5**.
43. Y. Zhang, Z. Yan, K. Nan, D. Xiao, Y. Liu, H. Luan, H. Fu, X. Wang, Q. Yang, J. Wang, W. Ren, H. Si, F. Liu, L. Yang, H. Li, J. Wang, X. Guo, H. Luo, L. Wang, Y. Huang and J. A. Rogers, *Proc Natl Acad Sci U S A*, 2015, **112**, 11757-11764.
44. T. Castle, Y. Cho, X. Gong, E. Jung, D. M. Sussman, S. Yang and R. D. Kamien, *Physical review letters*, 2014, **113**, 245502.
45. Z. Yan, F. Zhang, J. Wang, F. Liu, X. Guo, K. Nan, Q. Lin, M. Gao, D. Xiao and Y. Shi, *Advanced Functional Materials*, 2016.
46. D. M. Sussman, Y. Cho, T. Castle, X. Gong, E. Jung, S. Yang and R. D. Kamien, *Proceedings of the National Academy of Sciences*, 2015, **112**, 7449-7453.
47. D. A. Dillard, B. Chen, T. Chang and Y.-H. Lai, *The Journal of Adhesion*, 1999, **69**, 99-120.
48. Y.-H. Lai, M. D. Rakestraw and D. A. Dillard, *International Journal of Solids and Structures*, 1996, **33**, 1725-1743.
49. M. Diab, T. Zhang, R. Zhao, H. Gao and K.-S. Kim, 2013.
50. K. Fukuda, Y. Takeda, Y. Yoshimura, R. Shiwaku, L. T. Tran, T. Sekine, M. Mizukami, D. Kumaki and S. Tokito, *Nature communications*, 2014, **5**.
51. D. Son, J. Lee, S. Qiao, R. Ghaffari, J. Kim, J. E. Lee, C. Song, S. J. Kim, D. J. Lee and S. W. Jun, *Nature nanotechnology*, 2014, **9**, 397-404.
52. M. Amjadi, K. U. Kyung, I. Park and M. Sitti, *Advanced Functional Materials*, 2016, **26**, 1678-1698.
53. M. Amjadi, Y. J. Yoon and I. Park, *Nanotechnology*, 2015, **26**, 375501.
54. Y. Ma, M. Pharr, L. Wang, J. Kim, Y. Liu, Y. Xue, R. Ning, X. Wang, H. U. Chung and X. Feng, *small*, 2017, **13**.
55. Y. Su, X. Ping, K. J. Yu, J. W. Lee, J. A. Fan, B. Wang, M. Li, R. Li, D. V. Harburg, Y. Huang, C. Yu, S. Mao, J. Shim, Q. Yang, P. Y. Lee, A. Armonas, K. J. Choi, Y. Yang, U. Paik, T. Chang, T. J. Dawidczyk, Y. Huang, S. Wang and J. A. Rogers, *Adv Mater*, 2017, **29**.
56. D.-H. Kim, J. Song, W. M. Choi, H.-S. Kim, R.-H. Kim, Z. Liu, Y. Y. Huang, K.-C. Hwang, Y.-w. Zhang and J. A. Rogers, *Proceedings of the National Academy of Sciences*, 2008, **105**, 18675-18680.
57. D. S. Gray, J. Tien and C. S. Chen, *Advanced Materials*, 2004, **16**, 393-397.
58. A. Mamidanna, Z. Song, C. Lv, C. S. Lefky, H. Jiang and O. J. Hildreth, *ACS Appl Mater Interfaces*, 2016, **8**, 12594-12598.

59. C. Lv, H. Yu and H. Jiang, *Extreme Mechanics Letters*, 2014, **1**, 29-34.
60. J.-K. Jiang, J.-H. Chiu and J.-K. Lin, *Diseases of the colon & rectum*, 1999, **42**, 1152-1159.
61. S. A. Mazzuca, M. C. Page, R. D. Meldrum, K. D. Brandt and S. Petty - Saphon, *Arthritis Care & Research*, 2004, **51**, 716-721.
62. W. Zeng, L. Shu, Q. Li, S. Chen, F. Wang and X. M. Tao, *Advanced Materials*, 2014, **26**, 5310-5336.

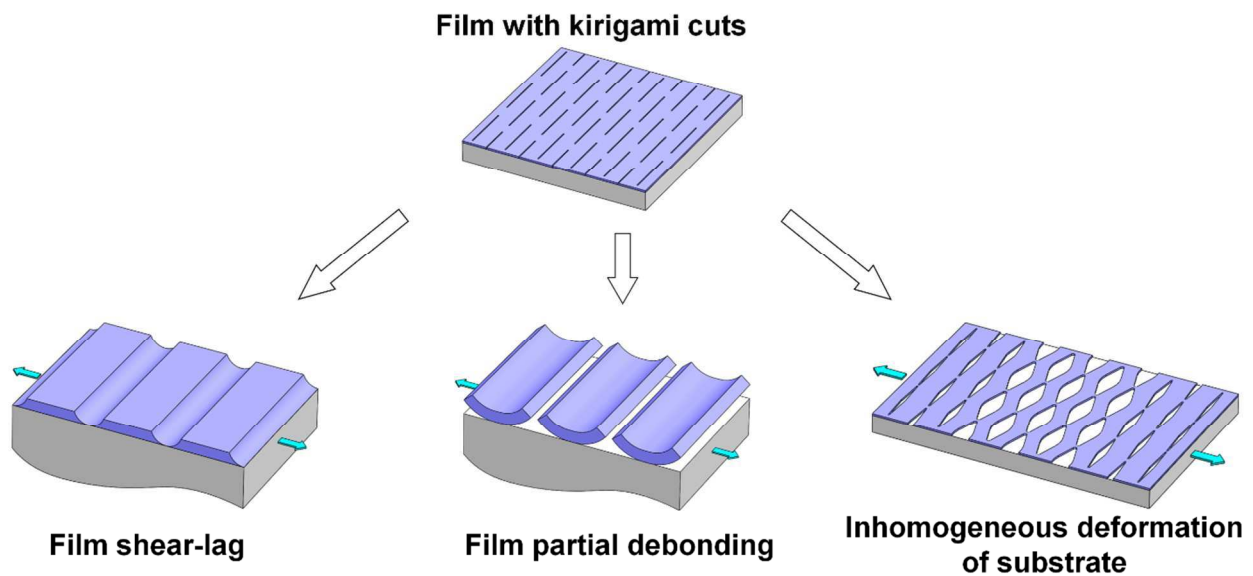
Table of Contents for

Kirigami Enhances Film Adhesion

Ruike Zhao^a, Shaoting Lin^a, Hyunwoo Yuk^a, and Xuanhe Zhao^{*ab}

a Department of Mechanical Engineering, Massachusetts Institute of Technology, Cambridge, MA 02139, USA, E-mail: zhaox@mit.edu

b Department of Civil and Environmental Engineering, Massachusetts Institute of Technology, Cambridge, MA 02139, USA.



Kirigami enhances film adhesion due to i) shear-lag effect of the film segments; ii) partial debonding at the film segments' edges; and iii) compatibility of kirigami films with inhomogeneous deformation of substrates.